EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	128	($5lithography and (AFM or (atomic adj force))).clm.	US-PGPUB; USPAT	OR	OFF	2007/09/07 12:39
S3	10	(("6391217") or ("6249747") or ("5856967") or ("5808302") or ("5729026")).PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/07 12:28
S4	10	((lyuksyutov near2 sergei)(juhl near2 shane)(vaia near2 richard)).in.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/07 12:29
S5	1176	(216/2).CCLS.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/07 12:37
S6	41	(pattern$3 and volt$3 and (AFM or (atomic adj force))).clm.	US-PGPUB; USPAT	OR	OFF	2007/09/07 12:40
S7	146	($5lithography and (AFM or STM or (atomic adj force) (scanning adj tunneling)))	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/07 12:46
S8	136	($5lithography and (AFM or STM or (atomic adj force) (scanning adj tunneling))).clm.	US-PGPUB; USPAT	OR	OFF	2007/09/07 12:45
S9	44	($5lithography and polymer$1 and (AFM or STM or (atomic adj force) (scanning adj tunneling))).clm.	US-PGPUB; USPAT	OR	OFF	2007/09/07 12:46
S10	12	($5lithography and polymer$1 and (AFM or STM or (atomic adj force) (scanning adj tunneling)))	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/07 12:46
S11	135	(joule adj heat$3) and (atomic adj force)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:39
S12	3	electrostatic adj nanolithography	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:56
S13	54	S11 and $5lithography	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:38

EAST Search History

S14	4866	($5lithography or lithographic or nanopattern$3) and (atomic adj force)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:40
S15	2579	($5lithography or lithographic or nanopattern$3) and (atomic adj force) and volt$4	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:40
S16	9	($5lithography or lithographic or nanopattern$3) and (atomic adj force) and volt$4	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:41
S17	18	(($5lithography or lithographic or nanopattern$3) and (atomic adj force) and volt$4).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 15:02
S18	41	(($5lithography or lithographic or nanopattern$3) and (atomic adj force) and electric$4).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:41
S19	1	("7241992").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:56
S20	44	electrostatic adj3 $6lithography	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/17 00:52
S21	114	($5lithography and (AFM or (atomic adj force)))	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:58
S22	28	($5lithography and (AFM or (atomic adj force))) and (electric$3 or volt$5)	EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2007/09/15 14:58